



TEC100.001DV1

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Baklanov, et al.  
Appl. No. : 09/844,959  
Filed : April 27, 2001  
For : FLUORINATED HARD MASK  
FOR MICROPATTERNING OF  
POLYMERS  
Examiner : Trinh, H. B.  
Group Art Unit : 2814

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 19, 2004

(Date)

John M. Carson, Reg. No. 34,303

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed July 20, 2004, Applicants respectfully request that the Examiner consider the following remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.